



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/905,320
Filing Date July 13, 2001
Inventor Cem Basceri, et al.
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner E. Fuller
Attorney's Docket No. MI22-1657

Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate
Comprising Dielectric Layers, Including Such Layers Having a Varied
Concentration of Barium and Strontium Within the Layer

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

To: Assistant Commissioner for Patents
Washington, D.C. 20231

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Dear Sir:

The Examiner's attention is directed to the references which are listed on
the attached Form PTO-1449 and copies of which are attached.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified
under 37 C.F.R. § 1.17(p).

03/28/2002 MAHMED1-00000042 09905286

01 FC:126

180.00 DP

Respectfully submitted,

Dated: 3/21/02

By: [Signature]

Mark S. Matkin
Reg. No. 32,268

Adjustment date: 03/29/2002 MAHMED1-
03/28/2002 MAHMED1-00000042 09905286

01 FC:126

-180.00 DP

03/29/2002 MAHMED1-00000075 09905320
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